

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
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Examiner		Art Unit		Page 1 of 1
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NON-PATENT DOCUMENTS

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	U	Isomura, Ikunao "A new inspection method for PSM on DUV inspection light source" 2001, IEEE, 31C-3-3
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.